



Docket No.: 0171-1022P
(PATENT)

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of:
Takeshi KINSHO et al.

Application No.: 10/671,732

Confirmation No.: 6775

Filed: September 29, 2003

Art Unit: 1752

For: POLYMERIZABLE SILICON-CONTAINING
COMPOUND, MANUFACTURING METHOD,
POLYMER, RESIST COMPOSITION AND
PATTERNING PROCESS

Examiner: S. J. Lee

AMENDMENT IN RESPONSE TO NON-FINAL OFFICE ACTION

MS Amendment
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

INTRODUCTORY COMMENTS

In response to the Office Action dated July 7, 2005, please amend the above-identified

U.S. patent application as follows:

Amendments to the Claims are reflected in the listing of claims which begins on page 2
of this paper.

Remarks begin on page 10 of this paper.

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